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APPLICANTS Kwan-Yong Lim, Ichon-shi, KOREA, REPUBLIC OF; Heung-Jae Cho, Ichon-shi, KOREA, REPUBLIC OF; Jung-Ho Lee, Ichon-shi, KOREA, REPUBLIC OF; Se-Aug Jang, Ichon-shi, KOREA, REPUBLIC OF; Yong-Soo Kim, Ichon-shi, KOREA, REPUBLIC OF; Byung-Seop Hong, Ichon-shi, KOREA, REPUBLIC OF; Jae-Geun Ho, Ichon-shi, KOREA, REPUBLIC OF; Hong-Seon Yang, Ichon-shi, KOREA, REPUBLIC OF; Hyun-Chul Sohn, Ichon-shi, KOREA, REPUBLIC OF;					
** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2003-43087 06/30/2003					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/27/2004					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 8	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 2
ADDRESS 43569					
TITLE Method for fabricating gate-electrode of semiconductor device with use of hard mask					
FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		